## STRAIN-SENSITIVITY OF STRUCTURES OF THE Au-Si $\langle Ni \rangle$ -Sb TYPE AT UNIFORM PRESSURE

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Summary

We research the strain-sensitivity of structures with Shottky barriers made on the basis of Si $\langle Ni \rangle$  with different specific resistance. It is shown that maximal strainsensitivity is observed in structures whose bases have specific resistance equal to  $\rho = 10^3$  Ohm·cm. It is shown that the strain-sensitivity depends on the applied voltage and has a maximal value under the voltage U = 2,5 V.